

1 Synthesis, Characterization, Volatility, and Thermal
2 Stability of Fluorinated Copper(II) Aminoalkoxide
3 Complexes as Potential Vapour Deposition Precursors

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14 ABSTRACT

15 The sodium aminoalkoxides $\text{Na}[\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMeR}']$ $\{\text{R} = \text{H}, \text{R}' = \text{Me} \text{ (1a)}; \text{R} = \text{R}' = \text{Me} \text{ (1b)}; \text{R} =$
16 $\text{CF}_3, \text{R}' = \text{Me} \text{ (1c)}; \text{R} = \text{Me}, \text{R}' = \text{Et} \text{ (1d)}; \text{R} = \text{CF}_3, \text{R}' = \text{Et} \text{ (1e)}\}$ were synthesized by reaction of the
17 corresponding fluorinated epoxide $\{\text{OCH}_2\text{CR}(\text{CF}_3); \text{R} = \text{H} \text{ (A)}, \text{Me} \text{ (B)}, \text{CF}_3 \text{ (C)}\}$ with a secondary amine
18 (HNMe_2 or HNMeEt), followed by deprotonation with sodium hydride. Compounds **1a-e** were isolated
19 as white powders and characterized by combustion elemental analysis and NMR spectroscopy. Epoxides
20 **A** and **C** are commercially available, while epoxide **B** was prepared by *in-situ* deprotonation and
21 alkylation of **A**. Reactions of **1a-e** with copper(II) chloride in THF afforded $[\text{Cu}\{\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMeR}'\}_2]$
22 $\{\text{R} = \text{H}, \text{R}' = \text{Me} \text{ (2a)}; \text{R} = \text{R}' = \text{Me} \text{ (2b)}; \text{R} = \text{CF}_3, \text{R}' = \text{Me} \text{ (2c)}; \text{R} = \text{Me}, \text{R}' = \text{Et} \text{ (2d)}; \text{R} = \text{CF}_3, \text{R}' = \text{Et}$
23 $\text{ (2e)}\}$; compounds **2b** and **2c** have previously been reported but not structurally characterized, while **2a**,
24 **2d**, and **2e** are new to this report. All copper(II) compounds were characterized by combustion elemental
25 analysis and single crystal X-ray crystallography. The physical properties of **2a-e** were also evaluated
26 using thermogravimetric analysis (TGA), melting point, and sublimation (at 5 mTorr) data, with
27 comparison to previously reported non-fluorinated $[\text{Cu}\{\text{OCHMeCH}_2\text{NMe}_2\}_2]$ (**III**; $[\text{Cu}(\text{dmap})_2]$).

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31 **Keywords:** Copper complexes, ALD precursors, Fluorinated ligands, Aminoalkoxide ligands, Thermal
32 stability & volatility

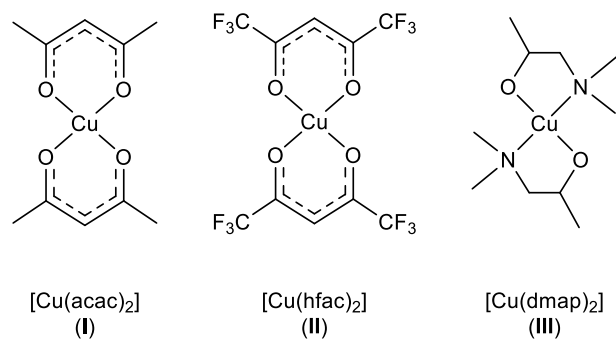
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34 Introduction

35 Copper metal, which possesses a low resistivity and high resistance to electromigration, is traditionally
36 used as the interconnect material for integrated circuits, which includes the nano-scale wiring to transmit
37 electrical signals between transistors.¹ However, as the physical dimensions of transistors decrease and
38 their complexity increases, there is growing demand for techniques to deposit ultra-thin copper films with
39 a higher degree of uniformity, conformality, and purity.^{1b,2} Atomic layer deposition (ALD) is a thin film
40 deposition method that can be used to deposit films which are more uniform and conformal than those
41 accessible via other methods, such as physical vapour (PVD) and chemical vapour deposition (CVD).³
42 ALD relies upon self-limiting, surface-based chemical reactions between molecules, namely a precursor
43 and a co-reactant, which are delivered to the substrate surface in the vapour phase. Notably, an ideal ALD
44 precursor will display high thermal stability and volatility, as well as suitable reactivity towards a given
45 co-reactant.^{3,4}

46 A challenge in copper metal ALD^{3e,5} is the agglomeration of ultra-thin copper films at deposition
47 temperatures above 100 °C, ultimately leading to discontinuous films.⁶ Copper precursors which offer
48 increased volatility (while maintaining high reactivity and thermal stability) are therefore of particular
49 interest, since they could enable vapour-phase delivery into the ALD reactor at lower temperature. When
50 comparing the known compounds bis(2,4-pentanedionato)copper(II), [Cu(acac)₂], and bis(1,1,1,5,5,5-
51 hexafluoro-2,4-pentanedionato)copper(II), [Cu(hfac)₂] (**I** and **II** in **Figure 1**), it is notable that fluorination
52 of the ligand backbone leads to *substantially* improved volatility.⁷ Accordingly, when used as a precursor
53 for vapour deposition, [Cu(hfac)₂] is deliverable at a significantly lower temperature than non-fluorinated
54 [Cu(acac)₂].⁸ Similar ligand fluorination strategies have been employed to increase the volatility of
55 precursor molecules throughout the periodic table,⁹ and in an extension of this line of thinking, we sought
56 to investigate the influence of fluorination on the volatility of copper(II) aminoalkoxide complexes.
57 Throughout academic and patent literature, a benchmark compound for low-temperature vapour
58 deposition of copper metal, especially in the context of ALD, is the copper(II) aminoalkoxide **III**
59 (bis(dimethylamino-2-propoxy)copper(II), [Cu(dmap)₂]) (**Figure 1**).^{10,11,12} This compound displays high

60 volatility and thermal stability, making it an attractive precursor for various ALD processes.¹³ A range of
 61 non-fluorinated analogues have also been described in the journal or patent literature.^{10, 11b, 11c, 12b} Herein,
 62 we present the synthesis and characterization of the sodium salts of a series of fluorinated aminoalkoxide
 63 ligands, and assessment of the influence of ligand substitution on the physical properties (especially
 64 volatility and melting point) of the corresponding homoleptic copper(II) complexes,
 65 $[\text{Cu}\{\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMe}_2\}_2]$ ($\text{R} = \text{H}, \text{Me}$ or CF_3) and $[\text{Cu}\{\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMeEt}\}_2]$ ($\text{R} = \text{Me}$ or CF_3).
 66 The compounds featuring one methyl and one ethyl group on the amine donor were synthesized to explore
 67 the potential for increased ligand asymmetry to improve volatility,¹⁴ and for longer chain alkyl
 68 substituents to afford complexes with lower melting points (ethyl substituents were used in order to
 69 minimize molecular weight, in an effort to maximize volatility, and to maintain a low degree of steric
 70 hindrance at the amine donor). Two of the five tertiary amine-containing copper complexes in this work,
 71 $[\text{Cu}\{\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMe}_2\}_2]$ ($\text{R} = \text{Me}$ and CF_3),^{12e} have previously been reported, and the related
 72 fluorinated derivatives $[\text{Cu}\{\text{OC}(\text{CF}_3)_2\text{CH}_2\text{NR}_2\}_2]$ ($\text{R} = \text{allyl},^{12c},^{12d} \text{CH}_2\text{CH}_2\text{OMe}^{12b-d}$) and
 73 $[\text{Cu}\{\text{OCH}(\text{CF}_3)\text{CH}_2\text{NR}_2\}_2]$ ($\text{R} = n\text{Pr}, \text{CH}_2\text{CH}_2\text{OMe}$)^{12c, 12d} have been described in the journal or patent
 74 literature.¹²

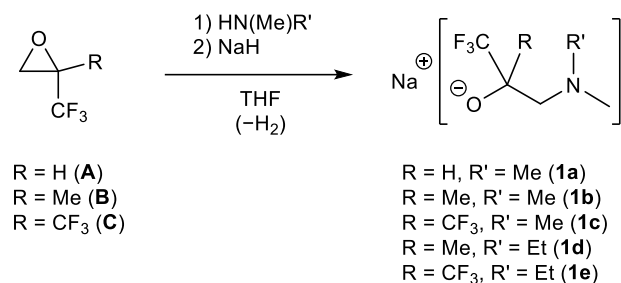


76 **Figure 1.** Select copper(II) precursors used for vapour deposition of copper metal.

79 Results and Discussion

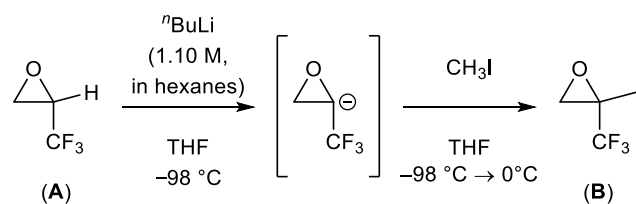
80 The sodium aminoalkoxides, $\text{Na}[\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMeR}']$ ($\text{R} = \text{H}, \text{R}' = \text{Me}$ (**1a**); $\text{R} = \text{R}' = \text{Me}$ (**1b**); $\text{R} =$
 81 $\text{CF}_3, \text{R}' = \text{Me}$ (**1c**); $\text{R} = \text{Me}, \text{R}' = \text{Et}$ (**1d**); $\text{R} = \text{CF}_3, \text{R}' = \text{Et}$ (**1e**)), were synthesized via a ring-opening

reaction of the corresponding fluorinated epoxides {OCH₂CR(CF₃); R = H (**A**), Me (**B**), CF₃ (**C**)} with a secondary amine (HNMe₂ or HNMeEt), followed by deprotonation with sodium hydride (**Scheme 1**). Compounds **1a-e** were isolated as white powders and characterized by combustion elemental analysis and NMR spectroscopy.



Scheme 1. Synthesis of sodium aminoalkoxide ligands **1a-e** via ring-opening of **A-C**.

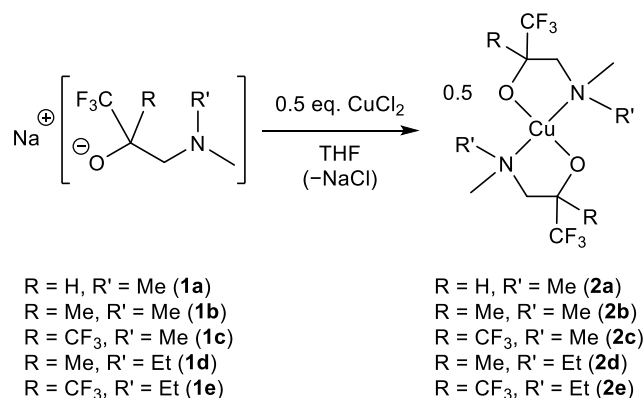
The commercial availability of **A** and **C** facilitated the synthesis of **1a**, **1c** and **1e**, while epoxide **B** (required for the synthesis of **1b** and **1d**) was prepared via *in-situ* deprotonation and alkylation of **A**. This deprotonation/alkylation method¹⁵ (**Scheme 2**) was chosen as an alternative to previous reports for the synthesis of **1b**, which utilized highly toxic and explosive diazomethane to generate **B**.^{12e}



Scheme 2. *In-situ* deprotonation and alkylation of epoxide **A** to form epoxide **B**.

Reaction of sodium aminoalkoxides **1a-e** with copper(II) chloride in THF afforded the corresponding paramagnetic copper(II) complexes [Cu{OCR(CF₃)CH₂NMeR'}₂] {R = H, R' = Me (**2a**); R = R' = Me (**2b**); R = CF₃, R' = Me (**2c**); R = Me, R' = Et (**2d**); R = CF₃, R' = Et (**2e**)} in fair to good yields (**Scheme 3**). Complexes **2b** and **2c** were previously reported in the literature as potential CVD precursors,^{12e} while

2a, **2d**, and **2e** are new to this report. The complexes are volatile, and can be purified by sublimation *in vacuo* (5 mTorr). All new complexes were characterized by combustion elemental analysis, melting point, and thermogravimetric analysis (*vide infra*). As **2a-e** are paramagnetic, their ^1H and ^{19}F NMR spectra (Figures S23 and S24) feature very broad peaks which, although they do not provide detailed structural information, can serve as a fingerprint for identification of these compounds. Compounds **2a-e** all contain tertiary alkyl amine groups, which avoids the potential for thermal decomposition involving dehydrogenation to afford an imine (which has been considered as a possible decomposition pathway for related copper(II) aminoalkoxide complexes containing secondary or primary amine groups),^{12b} potentially serving to increase the thermal stability of these complexes.



Scheme 3. Synthesis of copper(II) aminoalkoxide complexes **2a-e**.

Purple crystals of complexes **2a-e** were grown from concentrated toluene solutions and were characterized by single crystal X-ray diffraction (while **2b** and **2c** are known compounds, their crystal structures have not been previously reported). All compounds are square planar monomers, with a *trans* arrangement of the oxygen donors, and no close intermolecular contacts. In all instances except for **2d**, the copper centre is located at a special position (an inversion centre). The crystal structures of **2a-b** and **2d-e**, which contain at least one chiral centre in each ligand, exhibit some degree of disorder. However, it is notable that in both disorder components of **2a** and **2b**, the CF₃ groups are located on either side of the square plane (i.e. the molecules crystallize as *meso* (*RS*) diastereomers), and in both disorder components of **2e** the *N*-ethyl

groups are located on opposite sides of the square plane (i.e. **2e** also crystallizes as the *meso* (*RS*) diastereomer). By contrast, in both disorder components of **2d** (which has two chiral centres per ligand), (i) the CF₃ groups are located on opposite sides of the square plane and (ii) the ethyl groups are located on the same side of the square plane as each other (i.e. the alpha carbon atoms in both ligands have opposite chirality (*RS*), whereas the nitrogen atoms have the same chirality (*RR* or *SS*)); the major disorder component in the X-ray crystal structure of **2d** is shown in **Figure 2**. The Cu-O and Cu-N distances in **2a-e** (**Table 1**) range from 1.871(1)-1.887(2) Å and 2.031(1)-2.050(4) Å, respectively, which are comparable to those in other square planar copper(II) aminoalkoxide complexes (1.864(2)-1.897(2) Å and 2.017(2)-2.068(2) Å, respectively).^{12e,16} The O-Cu-O and N-Cu-N bond angles in **2a-c** and **2e** are 180° due to the inversion centre at copper, whereas the square planar geometry in **2d** is slightly distorted, with O-Cu-O and N-Cu-N angles of 178.6(1)° and 178.0(1)° for the major disorder component (90%).

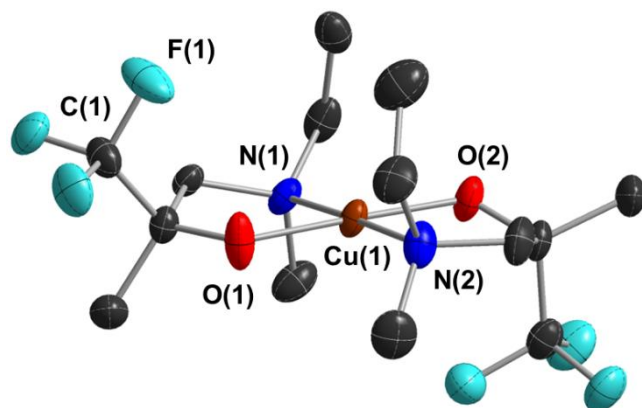


Figure 2. X-ray crystal structure of [Cu{κ²-OCMe(CF₃)CH₂NMeEt}₂] (**2d**). Hydrogen atoms are omitted, and only the major disorder component (90%) is included for clarity. Thermal ellipsoids are drawn at 50% probability.

Table 1. Cu-O and Cu-N distances in the X-ray crystal structures of **2a-e**. [Disorder of the CuO₂N₂ core is observed in **2b**, **2d** and **2e**; * major disorder component (78% in **2b**; 90% in **2d**; 55% in **2e**); ** minor disorder component].

Compound	Cu-O Distance (Å)	Cu-N Distance (Å)
2a	1.871(1)	2.031(1)
2b	1.876(2)	2.049(2)* 2.050(4)**
2c	1.881(1)	2.038(1)
2d	1.875(2)-1.887(2)* 1.880(2)-1.881(2)**	2.036(2)-2.049(2)* 2.039(5)-2.041(5)**
2e	1.883(3)* 1.881(3)**	2.040(3)* 2.047(3)**

Sublimation temperatures for compounds **2a-e** are listed in **Table 2**, and provide an indication of precursor volatility, although it is important to note that these data were obtained at a pressure of 5 mTorr, which is significantly lower than that in a typical ALD experiment (commonly 0.1-1.0 Torr). To evaluate the volatility (and thermal stability) of **2a-e** in more detail, thermogravimetric analysis (TGA) of **2a-e** was conducted in an argon-filled glovebox at atmospheric pressure (**Figure 3**). The non-fluorinated copper(II) aminoalkoxide compound **III** (**Figure 1**) was also synthesized and subjected to TGA under identical experimental conditions; compound **III** has been widely employed as a highly volatile vapour deposition precursor (*vide supra*), and thus comparison of the TGA data for **2a-e** with **III** allows evaluation of the influence of ligand fluorination on precursor volatility (compound **2a** is the direct analogue of **III**, where one methyl group in **III** has been replaced by a CF₃ group).

Table 2. Summary of the thermal properties of compounds **2a-e** and **III**.

Compound	Sublimation Temperature (°C; 5 mTorr)	TGA T _{50%} (°C)	TGA Onset Temperature (°C)	TGA Residual Mass (%)	1 Torr Temperature from TGA (°C)	Melting Point (°C)
2a	50-60	178	165	0.97	125	193-195
2b	35-45	151	141	0.45	100	148-149

2c	40-50	169	156	0.23	116	184-185
2d	35-45	149	136	1.85	88	65-66
2e	40-50	161	149	0.15	103	139-140
III	35-45	151	138	1.51	97	134-135

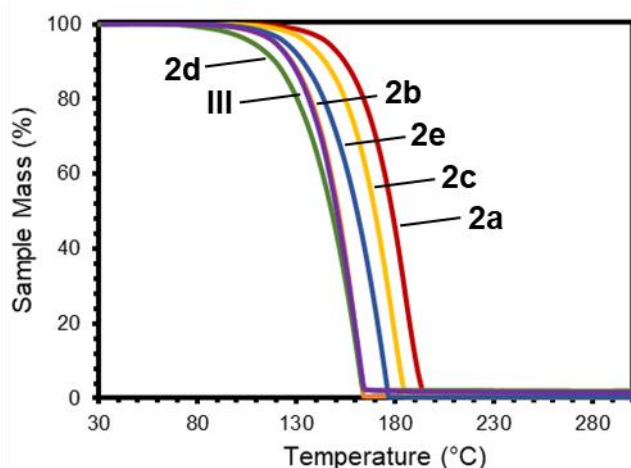


Figure 3. TGA mass loss curves for compounds **2a-e** and **III** with a heating rate of 10 °C/min at atmospheric pressure in an Ar-filled glovebox. Sample masses used: **2a** = 3.692 mg; **2b** = 3.660 mg; **2c** = 5.163 mg; **2d** = 1.925 mg; **2e** = 4.149 mg; **III** = 3.377 mg.

All six compounds (**2a-e** and **III**) display a single mass loss step in the TGA, leaving minimal residual mass, consistent with clean volatilization and thermal stability under the experimental conditions (on the short timescale of the TGA experiment). The mass loss curves of the investigated compounds are remarkably similar, with subtle differences in their volatility indicated by differing onset and 50% mass loss temperatures ($T_{50\%}$) (**Table 2**). The most asymmetric complex, **2d**, is the most volatile, while **2b** and **III** display nearly identical mass loss curves, and the direct trifluoromethyl analogue of **III**, compound **2a**, is the least volatile. The latter result is contrary to our original hypothesis that ligand fluorination would serve to improve the volatility of the corresponding copper aminoalkoxide. The temperatures at which **2a-e** and **III** would achieve a vapour pressure of 1 Torr (**Table 2**) were also calculated from the TGA data using standard methodologies (described further in the supporting information)¹⁷ with ferrocene

as the calibrant. However, it is important to note that the calculation of a 1 Torr temperature is subject to several assumptions, and serves more as an estimate of vapour pressure that allows for comparisons to be made between similar precursors than as an absolute value.¹⁸

Melting points are also included in **Table 2**. When considering vapour-phase delivery, the sublimation rate of a solid precursor will be dependent on the average particle size, which will change over time.¹⁹ In contrast, the evaporation rate of a liquid precursor should not be subject to such deviations, thereby ensuring a more consistent rate of precursor delivery. Additionally, precursors which are liquid at the delivery temperature avoid potential issues with (i) concentration of impurities at the solid surface as the precursor is consumed, hindering further volatilization,¹⁹ (ii) the transport of fine solid particles into the reactor, and (iii) valve or delivery tube blockages caused by sublimation and deposition (the reverse process of sublimation) of a solid precursor resulting from small temperature differences within the precursor delivery vessel (anywhere between the inlet and outlet valves to/from the vessel). Thus, from a practical perspective, precursors which are liquids at the delivery temperature are highly desirable. Melting points were determined by heating a flame-sealed capillary containing **2a-e** or **III** (packed under argon) in a melting point apparatus. Comparing compound **2a** with **III** reveals that incorporation of a trifluoromethyl group on the ligand backbone serves to increase the melting point of the copper complex compared to the non-fluorinated derivative. By contrast, the melting point of **2d** (65-66 °C) is significantly lower than that of the other complexes (134-195 °C), and **2d** is also the most volatile of the species in this report, presumably due to the longer alkyl chain on nitrogen and the overall asymmetry of the ligands¹⁴ in **2d**, rather than as a direct result of ligand trifluoromethylation.

Summary and Conclusions

A family of fluorinated copper(II) aminoalkoxide complexes, $[\text{Cu}\{\text{OCR}(\text{CF}_3)\text{CH}_2\text{NMeR}'\}_2]$ $\{\text{R} = \text{H}, \text{R}' = \text{Me} \text{ (2a)}; \text{R} = \text{R}' = \text{Me} \text{ (2b)}; \text{R} = \text{CF}_3, \text{R}' = \text{Me} \text{ (2c)}; \text{R} = \text{Me}, \text{R}' = \text{Et} \text{ (2d)}; \text{R} = \text{CF}_3, \text{R}' = \text{Et} \text{ (2e)}\}$, were synthesized and structurally characterized by single crystal X-ray diffraction and combustion elemental analysis. Compounds **2b** and **2c** have previously been reported, but not structurally characterized, while **2a**, **2d**, and **2e** are new to this work. The volatility, thermal stability and melting points of **2a-e** were evaluated by atmospheric pressure TGA, as well as sublimation (5 mTorr) and melting point data. For comparison, analogous measurements were also performed on the commonly employed non-fluorinated copper(II) aminoalkoxide precursor $[\text{Cu}\{\text{OCHMeCH}_2\text{NMe}_2\}_2]$ (**III**; $[\text{Cu}(\text{dmap})_2]$). All six compounds (**2a-e** and **III**) were found to undergo a single mass loss step in the TGA, leaving minimal residual mass, consistent with clean volatilization. Compound **2a**, which is the direct fluorinated analogue of **III** (with one CH_3 group replaced by a CF_3 group) is less volatile than **III**, with a significantly higher melting point (193-195 °C vs 134-135 °C). By contrast, **2d** is slightly more volatile than the other complexes, and has a substantially lower melting point (65-66 °C vs 134-195 °C), likely due to the longer alkyl chain on nitrogen and the overall asymmetry of the ligands, rather than as a direct result of ligand trifluoromethylation. Overall, complexes **2a-e** display sufficient volatility and thermal stability for implementation in novel vapour deposition processes, and compound **2d** offers the added benefit of a low melting point; ALD precursors which are liquid at the delivery temperature are desirable to avoid changes in the rate of precursor delivery resulting from changes in surface area, hindered volatilization due to concentration of impurities at a solid surface, transport of fine particles into the reactor, and valve or delivery tube blockages caused by sublimation and deposition (the reverse process of sublimation).

Experimental Section

General Details: An argon-filled MBraun UNIlab or Innovative Technology PureLab HE glove box equipped with a -35 °C freezer was employed for the manipulation and storage of all air-sensitive compounds, and reactions were performed on a double manifold vacuum line using standard techniques.²⁰

221 The vacuum was measured periodically using a Kurt J. Lesker 275i convection-enhanced Pirani gauge.
222 Residual oxygen and moisture were removed from the argon stream by passage through an Oxisorb-W
223 scrubber from Matheson Gas Products. Centrifugation was carried out using a Benchmark Hermle Z206A
224 centrifuge housed within a glove box.

225 Hexanes, toluene, diethyl ether, and tetrahydrofuran were purchased from Sigma-Aldrich, and
226 deuterated solvents were purchased from Cambridge Isotope Laboratories. Solvents were initially dried
227 and distilled at atmospheric pressure from sodium/benzophenone (hexanes, diethyl ether, tetrahydrofuran,
228 C₆D₆, d₈-THF) or sodium (toluene). All solvents were stored over sodium/benzophenone and introduced
229 to reactions or solvent storage flasks via vacuum transfer with condensation at -78 °C. Epoxides **A** and
230 **B** were purchased from SynQuest Laboratories and distilled to solvent storage flasks via vacuum transfer
231 with condensation at -78 °C prior to use. Complex **III** was synthesized according to literature
232 procedures.^{10a} Dimethylamine (2.0 M in THF), *N*-ethylmethylamine, methyl iodide, sodium hydride,
233 ^{*n*}BuLi (1.6 M in hexanes), copper(II) chloride, and copper(II) methoxide were purchased from Sigma-
234 Aldrich and used without further purification. 1-Dimethylamino-2-propanol was purchased from Sigma-
235 Aldrich and dried over 4 Å molecular sieves and distilled to a solvent storage flask via vacuum transfer
236 with condensation at -78 °C.

237 NMR spectroscopy was performed on a Bruker AV-600 spectrometer. All ¹H NMR and ¹³C NMR
238 spectra were referenced relative to SiMe₄ through the C₆D₆ or d₈-THF resonance or the protio impurity in
239 the C₆D₆ or d₈-THF solvent: 7.16 and 3.58 ppm, respectively, for ¹H NMR and 128.06 and 67.21 ppm,
240 respectively for ¹³C NMR. ¹⁹F NMR spectra were referenced by indirect referencing from a ¹H NMR
241 spectrum.²¹ Peak assignments in the spectra of all new diamagnetic compounds were made with the aid
242 of DEPT-q, COSY, HSQC and HMBC experiments.

243 Single-crystal X-ray crystallographic analyses were performed on crystals coated in Paratone oil
244 and mounted on either a Bruker SMART APEX II diffractometer with a 3 kW sealed tube Mo generator
245 and APEX II CCD detector or a STOE IPDS II diffractometer with an image plate detector in the
246 McMaster Analytical X-ray Diffraction Facility. Raw data was processed using XPREP (as part of the

247 APEX v2.2.0 software) and solved by an intrinsic method (SHELXT).²² In all cases, non-hydrogen atoms
248 were refined anisotropically. Hydrogen atoms were either located from the distance map or generated in
249 ideal positions and then updated with each cycle of refinement, which was performed with SHELXL in
250 OLEX2-1.5.^{23,24}

251 Combustion elemental analyses were performed by Midwest Microlabs in Indianapolis, Indiana
252 or at the University of Calgary using a Perkin Elmer Model 2400 series II analyzer. Thermogravimetric
253 analysis was performed by Green Centre Canada in Kingston, Ontario using a TA Instruments Discovery
254 TGA located within an argon-filled glove box. Melting point determinations were performed by packing
255 the analyte into a flame-sealed pipette and sealing the open face of the pipette with Apiezon H-grease
256 inside an argon-filled glovebox. The pipette was then removed from the glovebox and quickly flame-
257 sealed (below the grease but sufficiently distant from the analyte) to form a sealed capillary, which was
258 in turn used for analysis using a DigiMelt Melting Point Apparatus.

259

260 **Synthetic Details:**

261 **Na[OCH(CF₃)CH₂NMe₂] (1a):** Under an inert atmosphere, 0.806 g (7.19 mmol) of
262 2-(trifluoromethyl)oxirane (**A**) was charged to a 25 mL flask containing 5 mL of THF. The flask was
263 cooled to 0 °C and 7.91 mmol of dimethylamine (4.52 mL of a 1.75 M solution in THF) was added
264 dropwise with stirring. The reaction was stirred for 30 minutes at 0 °C, followed by stirring at room
265 temperature for 14 hours. The solvent and excess dimethylamine were removed at 0 °C *in vacuo* to yield
266 0.991 g (6.31 mmol) of a white crystalline powder. This powder was redissolved in 5 mL of THF, and the
267 resulting solution was added dropwise to a cooled (0 °C) 50 mL flask containing 0.167 g (6.94 mmol) of
268 sodium hydride suspended in 10 mL of THF. The reaction mixture was stirred for 4 hours at room
269 temperature and then evaporated to dryness *in vacuo*. Excess sodium hydride was removed by
270 centrifugation after addition of 5 mL of THF, and the resultant solution was evaporated to dryness *in*
271 *vacuo* to yield 1.064 g (5.94 mmol) of **1a** as a white powder (83% yield from **A**). This product is pure by
272 NMR spectroscopy, and was used in all subsequent reactions. However, elemental analysis was carried

out on crystals obtained by dissolving a sample of **1a** in a 3:1 mixture of hot toluene and THF, followed by cooling to $-35\text{ }^{\circ}\text{C}$. ^1H NMR (d_8 -THF, 600 MHz, 298 K): δ 4.19-4.24 (*m*, 1H, $\text{CH}(\text{CF}_3)$), 2.35 (*t*, 1H, $^2J_{\text{H,H}}/^3J_{\text{H,H}} = 10.8\text{ Hz}$, CH_2), 2.23 (*s*, 6H, $\text{N}(\text{CH}_3)_2$), 2.03 (*d*, 1H, $^2J_{\text{H,H}} = 10.8\text{ Hz}$, CH_2). $^{13}\text{C}\{^1\text{H}\}$ NMR (d_8 -THF, 151 MHz, 298 K): δ 129.89 (*q*, $^1J_{\text{C,F}} = 287.4\text{ Hz}$, CF_3), 72.40 (*q*, $^2J_{\text{C,F}} = 25.4\text{ Hz}$, $\text{C}(\text{CF}_3)$), 65.59 (*s*, CH_2), 45.83 (*s*, $\text{N}(\text{CH}_3)_2$). ^{19}F NMR (d_8 -THF, 565 MHz, 298 K): δ -82.29 (*d*, $^3J_{\text{F,H}} = 4.0\text{ Hz}$, CF_3). Anal. Calcd. for $\text{C}_5\text{H}_9\text{F}_3\text{NNaO}$ (%): C, 33.52; H, 5.07; N 7.82. Found: C, 33.53; H, 5.04; N, 7.50.

Na[OCMe(CF₃)CH₂NMe₂] (1b): Under an inert atmosphere, 2.120 g (18.92 mmol) of 2-(trifluoromethyl)oxirane (**A**) was charged to a 250 mL flask containing 100 mL of THF and subsequently cooled to $-98\text{ }^{\circ}\text{C}$. A 1.10 M solution of *n*BuLi in hexanes (20 mL; 22.00 mmol) was then added dropwise over the course of 15 minutes. This solution was stirred for an additional 10 minutes at $-98\text{ }^{\circ}\text{C}$, whereupon 4.600 g (32.41 mmol) of methyl iodide was added. The reaction mixture was stirred for 1 hour at $-98\text{ }^{\circ}\text{C}$ and then for an additional hour at $-78\text{ }^{\circ}\text{C}$, whereupon the reaction temperature was raised to $0\text{ }^{\circ}\text{C}$. 70 mmol of dimethylamine (40.00 mL of 1.75 M solution in THF) was then added slowly, and the reaction was stirred for 30 minutes at $0\text{ }^{\circ}\text{C}$, followed by stirring at room temperature for 14 hours. The reaction mixture was then quenched with 90 mL of a saturated ammonium chloride solution, the organic layer separated, and the aqueous layer extracted with 3 x 50 mL of diethyl ether. All organic layers were combined, washed with 80 mL of a brine solution, and dried with magnesium sulfate. Solvent was removed on a rotary evaporator, and the residual orange oil was distilled under vacuum to yield 3.191 g of a clear, colourless oil. This oil was then dissolved in 5 mL of dry and degassed THF and added dropwise to a $0\text{ }^{\circ}\text{C}$ suspension of sodium hydride (0.491 g; 21.00 mmol) in 40 mL of THF. The mixture was stirred for 4 hours at room temperature, filtered, and the filtrate was evaporated to dryness *in vacuo* to yield 2.467 g (13.00 mmol) of **1b** as a white solid (68% yield from **A**). This product is pure by NMR spectroscopy, and was used in all subsequent reactions. However, elemental analysis was carried out on crystals obtained by dissolving a sample of **1b** in hot toluene, followed by cooling to $-35\text{ }^{\circ}\text{C}$. ^1H NMR (d_8 -THF, 600 MHz,

298 K): δ 2.43-2.46 (*m*, 1H, CH_2), 2.33 (*s*, 6H, $\text{N}(\text{CH}_3)_2$), 2.19-2.23 (*m*, 1H, CH_2), 1.16 (*s*, 3H, CH_3).
13C{1H} NMR (d_8 -THF, 151 MHz, 298 K): δ 131.06 (*q*, $^1J_{\text{C,F}} = 297.0$ Hz, CF_3), 75.48 (*br s*, $\text{C}(\text{CF}_3)$),
69.15, 69.08 ($2 \times m$, CH_2)[†], 49.41, 49.33, 49.26 ($3 \times m$, $\text{N}(\text{CH}_3)_2$)[†], 26.25, 26.16, 26.09 ($3 \times m$, CH_3)[†]. 19F
NMR (d_8 -THF, 565 MHz, 298 K): δ -83.85, -83.95, -84.00 ($3 \times m$, CF_3)[†]. Anal. Calcd. for $\text{C}_6\text{H}_{11}\text{F}_3\text{NNaO}$
(%): C, 37.30; H, 5.75; N 7.25. Found: C, 37.76; H, 6.13; N, 7.18. [†] Multiple peaks are likely due to
diastereomers resulting from aggregation.

Na[OC(CF₃)₂CH₂NMe₂] (1c): Under an inert atmosphere, 1.878 g (10.43 mmol) of 2,2-bis(trifluoromethyl)oxirane (**C**) was charged to a 25 mL flask containing 5 mL of THF. The flask was cooled to 0 °C and 11.47 mmol of dimethylamine (6.55 mL of a 1.75 M solution in THF) was added dropwise with stirring. The reaction was stirred for 30 minutes at 0 °C, followed by stirring at room temperature for 14 hours. The solvent and excess dimethylamine were removed at 0 °C *in vacuo* to yield 1.744 g (7.74 mmol) of a clear, light yellow oil. This oil was dissolved in 5 mL of THF and added dropwise to a cooled (0 °C) 50 mL flask containing 0.204 g (8.52 mmol) of sodium hydride suspended in 10 mL of THF. The reaction mixture was stirred for 4 hours at room temperature and then evaporated to dryness *in vacuo*. Excess sodium hydride was removed by centrifugation after addition of 5 mL of THF, and the resultant solution was evaporated to dryness *in vacuo* to yield 1.830 g (7.40 mmol) of **1c** as a white powder (71% yield from **C**). This product is pure by NMR spectroscopy, and was used in all subsequent reactions. However, elemental analysis was carried out on crystals obtained by dissolving a sample of **1c** in hot toluene, followed by cooling to -35 °C. 1H NMR (d_8 -THF, 600 MHz, 298 K): δ 2.52 (*s*, 2H, CH_2), 2.31 (*s*, 6H, $\text{N}(\text{CH}_3)_2$). 13C{1H} NMR (d_8 -THF, 151 MHz, 298 K): δ 127.62 (*q*, $^1J_{\text{C,F}} = 294.7$ Hz, CF_3), 81.63 (*sept*, $^2J_{\text{C,F}} = 23.6$ Hz, $\text{C}(\text{CF}_3)_2$), 62.70 (*s*, CH_2), 48.62 (*s*, $\text{N}(\text{CH}_3)_2$). 19F NMR (d_8 -THF, 565 MHz, 298 K): δ -79.38 (*s*, CF_3). Anal. Calcd. for $\text{C}_6\text{H}_8\text{F}_6\text{NNaO}$ (%): C, 29.16; H, 3.27; N 5.67. Found: C, 29.20; H, 3.40; N, 5.63.

323 **Na[OCMe(CF₃)CH₂NMeEt] (1d):** Under an inert atmosphere, 0.918 g (8.20 mmol) of 2-
 324 (trifluoromethyl)oxirane (**A**) was charged to a 100 mL flask containing 40 mL of THF and subsequently
 325 cooled to −98 °C. A 1.10 M solution of ⁿBuLi in hexanes (8.20 mL; 9.02 mmol) was then added dropwise
 326 over the course of 10 minutes. This solution was stirred for an additional 10 minutes at −98 °C, whereupon
 327 2.287 g (16.11 mmol) of methyl iodide was added. The reaction mixture was stirred for 1 hour at −98 °C
 328 and stirred for an additional hour at −78 °C, whereupon the reaction temperature was raised to 0 °C. 32.00
 329 mmol of *N*-ethylmethylamine (18.30 mL of a 1.75 M solution in THF) was then added slowly, and the
 330 reaction was stirred for 30 minutes at 0 °C, followed by stirring at room temperature for 14 hours. The
 331 reaction mixture was then quenched with 40 mL of a saturated ammonium chloride solution, the organic
 332 layer separated, and the aqueous layer extracted with 3 x 20 mL of diethyl ether. All organic layers were
 333 combined, washed with 40 mL of a brine solution, and dried with magnesium sulfate. Solvent was
 334 removed on a rotary evaporator, and the residual orange oil distilled under vacuum to yield 1.248 g (6.74
 335 mmol) of a clear, colourless oil. This oil was then dissolved in 5 mL of dry and degassed THF and added
 336 dropwise to a 0 °C suspension of sodium hydride (0.178 g; 7.42mmol) in 15 mL of THF. The mixture
 337 was stirred for 4 hours at room temperature, filtered, and evaporated to dryness *in vacuo* to yield 1.166 g
 338 (5.63 mmol) of **1d** as a white solid (69% yield from **A**). This product is pure by NMR spectroscopy, and
 339 was used in all subsequent reactions. However, elemental analysis was carried out on crystals obtained
 340 by cooling a concentrated toluene solution of **1d** to −35 °C. ¹H NMR (d₈-THF, 600 MHz, 298 K): δ 2.51-
 341 2.55 (*m*, 2H, N(CH₂CH₃)), 2.36 (*s*, 2H, CH₂), 2.31 (*s*, 3H, N(CH₃)), 1.16 (*s*, 3H, CH₃), 1.02 (*t*, 3H, ³J_{H,H} =
 342 7.1 Hz, N(CH₂CH₃)). ¹³C {¹H} NMR (d₈-THF, 151 MHz, 298 K): δ 131.28 (*q*, ¹J_{C,F} = 293.6 Hz, CF₃),
 343 75.44 (*q*, ²J_{C,F} = 22.1 Hz, C(CF₃)), 67.59* (CH₂), 55.00 (*s*, N(CH₂CH₃)), 44.31 (*s*, N(CH₃)), 25.99 (*s*, CH₃),
 344 11.95 (*s*, N(CH₂CH₃)). ¹⁹F NMR (d₈-THF, 565 MHz, 298 K): δ −83.18, −83.21, −83.26, −83.34, −83.47
 345 (5 × *m*, CF₃)[†]. Anal. Calcd. for C₇H₁₃F₃NNaO (%): C, 40.57; H, 6.34; N 6.76. Found: C, 40.40; H, 6.53;
 346 N, 6.70. * Peak obscured by d₈-THF solvent signal, identified by ¹H-¹³C HSQC. [†] Multiple peaks are likely
 347 due to diastereomers resulting from aggregation.

349 **Na[OC(CF₃)₂CH₂NMeEt] (1e):** Under an inert atmosphere, 0.500 g (2.78 mmol) of 2,2-
350 bis(trifluoromethyl)oxirane (**C**) was charged to a 25 mL flask containing 5 mL of THF. The flask was
351 cooled to 0 °C and 3.06 mmol of *N*-ethylmethylamine (1.75 mL of a 1.75 M solution in THF) was added
352 dropwise with stirring. The reaction was stirred for 30 minutes at 0 °C, followed by stirring at room
353 temperature for 14 hours. The solvent and excess *N*-ethylmethylamine were removed at 0 °C *in vacuo* to
354 yield 0.622 g (2.77 mmol) of a clear, light-yellow oil. This oil was dissolved in 5 mL of THF and added
355 dropwise to a cooled (0 °C) 50 mL flask containing 0.072 g (3.00 mmol) of sodium hydride suspended in
356 10 mL of THF. The reaction mixture was stirred for 4 hours at room temperature and then evaporated to
357 dryness *in vacuo*. Excess sodium hydride was removed by centrifugation after addition of 5 mL of THF,
358 and the resultant solution was evaporated to dryness *in vacuo* to yield 0.667 g (2.55 mmol) of **1e** as a
359 white powder (92% yield from **C**). This product is pure by NMR spectroscopy, and was used in all
360 subsequent reactions. However, elemental analysis was carried out on crystals obtained by cooling a
361 concentrated toluene solution of **1e** to -35 °C. ¹H NMR (d₈-THF, 600 MHz, 298 K): δ 2.57 (*s*, 2H, CH₂),
362 2.51 (*q*, 2H, ³J_{H,H} = 7.2 Hz, N(CH₂CH₃)), 2.32 (*s*, 3H, N(CH₃)), 1.01 (*t*, 3H, ³J_{H,H} = 7.2 Hz, N(CH₂CH₃)).
363 ¹³C{¹H} NMR (d₈-THF, 151 MHz, 298 K): δ 127.68 (*q*, ¹J_{C,F} = 295.3 Hz, CF₃), 81.61 (*br s*, C(CF₃)₂),
364 60.81 (*s*, CH₂), 54.49 (*s*, N(CH₂CH₃)), 44.35 (*s*, N(CH₃)), 12.13 (*s*, N(CH₂CH₃)). ¹⁹F NMR (d₈-THF, 565
365 MHz, 298 K): δ -79.26 (*s*, CF₃). Anal. Calcd. for C₇H₁₃F₃NNaO (%): C, 32.19; H, 3.87; N 5.36. Found:
366 C, 32.27; H, 4.07; N, 5.34.

367

368 **[Cu{OCH(CF₃)CH₂NMe₂}₂] (2a):** In an argon-filled glovebox, a solution containing 0.484 g (2.70
369 mmol) of **1a** in 5 mL of THF was added to a stirring suspension of CuCl₂ (0.182 g; 1.35 mmol) in 5 mL
370 of THF. The reaction mixture was stirred for 16 hours, filtered, and evaporated to dryness *in vacuo* to
371 yield a purple solid, which was purified by sublimation under vacuum (50-60 °C, 5 mTorr) to yield 0.262
372 g (0.70 mmol) of **2a** as a purple, crystalline solid (52% yield). X-ray quality crystals of **2a** were obtained

373 by cooling a concentrated toluene solution to $-35\text{ }^{\circ}\text{C}$. ^1H NMR (C_6D_6 , 600 MHz, 298 K): $\delta \sim 24$ (br s),
374 ~ 14 (br s). ^{19}F NMR (C_6D_6 , 565 MHz, 298 K): $\delta \sim (-58)$ (br s). Melting Point: $193\text{-}195\text{ }^{\circ}\text{C}$. Anal. Calcd.
375 for $\text{C}_{10}\text{H}_{18}\text{CuF}_6\text{O}_2\text{N}_2$ (%): C, 32.09; H, 4.65; N 7.82. Found: C, 31.95; H, 4.84; N, 7.46.

376

377 **[Cu{OCMe(CF₃)CH₂NMe₂}₂] (2b):** In an argon-filled glovebox, a solution containing 2.135 g (11.00
378 mmol) of **1b** in 10 mL of THF was added to a stirring suspension of CuCl_2 (0.740 g; 5.50 mmol) in 10
379 mL of THF. The reaction mixture was stirred for 16 hours, filtered, and evaporated to dryness *in vacuo* to
380 yield a purple solid, which was purified by sublimation under vacuum ($35\text{-}45\text{ }^{\circ}\text{C}$, 5 mTorr) to yield 1.922
381 g (4.76 mmol) of **2b** as a purple crystalline solid (87% yield). X-ray quality crystals of **2b** were obtained
382 by cooling a concentrated toluene solution to $-35\text{ }^{\circ}\text{C}$. ^1H NMR (C_6D_6 , 600 MHz, 298 K): $\delta \sim 15$ (br s). ^{19}F
383 NMR C_6D_6 , 565 MHz, 298 K): $\delta \sim (-86)$ (br s). Melting Point: $148\text{-}149\text{ }^{\circ}\text{C}$. Anal. Calcd. for
384 $\text{C}_{12}\text{H}_{22}\text{CuF}_6\text{O}_2\text{N}_2$ (%): C, 35.44; H, 5.84; N 6.77. Found: C, 35.69; H, 5.49; N, 6.94.

385

386 **[Cu{OC(CF₃)₂CH₂NMe₂}₂] (2c):** In an argon-filled glovebox, a solution containing 0.727 g (2.94 mmol)
387 of **1c** in 5 mL of THF was added to a stirring suspension of CuCl_2 (0.198 g; 1.47 mmol) in 5 mL of THF.
388 The reaction mixture was stirred for 16 hours, filtered, and evaporated to dryness *in vacuo* to yield a
389 purple solid, which was purified by sublimation under vacuum ($40\text{-}50\text{ }^{\circ}\text{C}$, 5 mTorr) to yield 0.558 g (1.09
390 mmol) of **2c** as a purple crystalline solid (74% yield). X-ray quality crystals of **2c** were obtained by cooling
391 a concentrated toluene solution to $-35\text{ }^{\circ}\text{C}$. ^1H NMR (C_6D_6 , 600 MHz, 298 K): No observable signals in
392 the range of ± 100 ppm. ^{19}F NMR (C_6D_6 , 565 MHz, 298 K): $\delta \sim (-68)$ (br s). Melting Point: $184\text{-}185$
393 $^{\circ}\text{C}$. Anal. Calcd. for $\text{C}_{12}\text{H}_{16}\text{CuF}_{12}\text{O}_2\text{N}_2$ (%): C, 27.99; H, 3.42; N 5.31. Found: C, 28.16; H, 3.15; N, 5.47.

394

395 **[Cu{ κ^2 -OCMe(CF₃)CH₂NMeEt}₂] (2d):** In an argon-filled glovebox, a solution containing 0.829 g (4.00
396 mmol) of **1d** in 5 mL of THF was added to a stirring suspension of CuCl_2 (0.269 g; 2.00 mmol) in 5 mL
397 of THF. The reaction mixture was stirred for 16 hours, filtered, and evaporated to dryness *in vacuo* to

yield a purple solid, which was purified by sublimation under vacuum (35-45 °C, 5 mTorr) to yield 0.694 g (1.61 mmol) of **2d** as a purple crystalline solid (81% yield). X-ray quality crystals of **2d** were obtained by cooling a concentrated hexanes solution to -35 °C. ¹H NMR (C₆D₆, 600 MHz, 298 K): δ ~18 (br s), ~11 (br s), ~10 (br s), ~8 (br s), ~7 (br s), ~3 (br s), ~2 (br s). ¹⁹F NMR (C₆D₆, 565 MHz, 298 K): δ ~(-70) (br s), ~(-87) (br s). Melting Point: 65-66 °C. Anal. Calcd. for C₁₄H₂₆CuF₆O₂N₂ (%): C, 39.06; H, 6.25; N, 6.60. Found: C, 38.92; H, 6.08; N, 6.49.

404

[Cu{OC(CF₃)₂CH₂NMeEt}₂] (2e): In an argon-filled glovebox, a solution containing 0.522 g (2.00 mmol) of **1e** in 5 mL of THF was added to a stirring suspension of CuCl₂ (0.134 g; 1.00 mmol) in 5 mL of THF. The reaction mixture was stirred for 16 hours, filtered, and evaporated to dryness *in vacuo* to yield a purple solid, which was purified by sublimation under vacuum (40-50 °C, 5 mTorr) to yield 0.419 g (0.78 mmol) of **2e** as a purple crystalline solid (78% yield). X-ray quality crystals of **2e** were obtained by cooling a concentrated toluene solution to -35 °C. ¹H NMR (C₆D₆, 600 MHz, 298 K): δ ~20 (br s), ~15 (br s), ~2 (br s). ¹⁹F NMR (C₆D₆, 565 MHz, 298 K): δ ~(-59) (br s), ~(-65) (br s), ~(-70) (br s). Melting Point: 139-140 °C. Anal. Calcd. for C₁₄H₂₀CuF₁₂O₂N₂ (%): C, 31.24; H, 3.60; N, 5.17. Found: C, 31.14; H, 3.74; N, 5.19.

414

ASSOCIATED CONTENT

Data Availability. ¹H, ¹³C{¹H}, ¹⁹F and selected 2D NMR spectra, and general X-ray crystal structure data and refinement details are provided in the Supporting Information. CCDC 2324430-2324434 contain the supplementary crystallographic data for compounds **2a-2e**, respectively. These data can be obtained, free of charge, via www.ccdc.cam.ac.uk/data_request/cif (or from the Cambridge Crystallographic Data Centre, 12 Union Road, Cambridge CB2 1EZ, UK; fax: +44 1223 336033; or email: deposit@ccdc.cam.ac.uk).

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423

COMPETING INTERESTS

There are no competing interests to declare.

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REFERENCES

- (1) (a) Li, Z.; Tian, Y.; Teng, C.; Cao, H. Recent Advances in Barrier Layer of Cu Interconnects. *Materials* **2020**, *13* (21), 5049. (b) Kim, H.-W. Recent Trends in Copper Metallization. *Electronics* **2022**, *11* (18), 2914. (c) Moon, J. H.; Jeong, E.; Kim, S.; Kim, T.; Oh, E.; Lee, K.; Han, H.; Kim, Y. K. Materials Quest for Advanced Interconnect Metallization in Integrated Circuits. *Adv. Sci.* **2023**, *10* (23), 2207321.
- (2) (a) Leskelä, M.; Ritala, M. Atomic Layer Deposition Chemistry: Recent Developments and Future Challenges. *Angew. Chem. Int. Ed.* **2003**, *42* (45), 5548-5554. (b) Kim, H. The application of atomic layer deposition for metallization of 65 nm and beyond. *Surf. Coat. Technol.* **2006**, *200* (10), 3104-3111.
- (3) (a) Vidjayacoumar, B.; Emslie, D. J. H.; Clendenning, S. B.; Blackwell, J. M.; Britten, J. F.; Rheingold, A. Investigation of AlMe₃, BEt₃, and ZnEt₂ as Co-Reagents for Low-Temperature Copper Metal ALD/Pulsed-CVD. *Chem. Mater.* **2010**, *22* (17), 4844-4853. (b) Knisley, T. J.; Kalutarage, L. C.; Winter, C. H. Precursors and chemistry for the atomic layer deposition of metallic first row transition metal films. *Coord. Chem. Rev.* **2013**, *257* (23), 3222-3231. (c) Miiikkulainen, V.; Leskelä, M.; Ritala, M.; Puurunen, R. L. Crystallinity of inorganic films grown by atomic layer deposition: Overview and general trends. *J. Appl. Phys.* **2013**, *113* (2), 021301. (d) Hagen, D. J.; Pemble, M. E.; Karppinen, M. Atomic layer

deposition of metals: Precursors and film growth. *Appl. Phys. Rev.* **2019**, 6 (4), 041309. (e) Gordon, P. G.; Kurek, A.; Barry, S. T. Trends in Copper Precursor Development for CVD and ALD Applications. *ECS J. Solid State Sci. Technol.* **2015**, 4 (1), N3188.

(4) Devi, A. ‘Old Chemistries’ for new applications: Perspectives for development of precursors for MOCVD and ALD applications. *Coord. Chem. Rev.* **2013**, 257 (23), 3332-3384.

(5) Tripathi, T. S.; Wilken, M.; Hoppe, C.; de los Arcos, T.; Grundmeier, G.; Devi, A.; Karppinen, M. Atomic Layer Deposition of Copper Metal Films from Cu(acac)₂ and Hydroquinone Reductant. *Adv. Eng. Mater.* **2021**, 23 (10), 2100446.

(6) (a) Dai, M.; Kwon, J.; Halls, M. D.; Gordon, R. G.; Chabal, Y. J. Surface and Interface Processes during Atomic Layer Deposition of Copper on Silicon Oxide. *Langmuir* **2010**, 26 (6), 3911-3917. (b) Park, K.-M.; Kim, J.-K.; Han, B.; Lee, W.-J.; Kim, J.; Shin, H.-K. Influence of the deposition temperature on the properties of copper thin films prepared by alternating injection of Cu(ethylketoimate)₂ and H₂ on a ruthenium substrate. *Microelectron. Eng.* **2012**, 89, 27-30. (c) Hagen, D. J.; Connolly, J.; Povey, I. M.; Rushworth, S.; Pemble, M. E. Island Coalescence during Film Growth: An Underestimated Limitation of Cu ALD. *Adv. Mater. Interfaces* **2017**, 4 (18), 1700274. (d) Yao, Y.; Chen, B.; Zaera, F. On the Mechanism of the Atomic Layer Deposition of Cu Films on Silicon Oxide Surfaces: Activation Using Atomic Hydrogen and Three-Dimensional Growth. *Chem. Mater.* **2023**, 35 (5), 2155-2164.

(7) Fahlman, B. D.; Barron, A. R. Substituent effects on the volatility of metal β-diketonates. *Adv. Mater. Opt. Electron.* **2000**, 10 (3-5), 223-232.

(8) Bernal Ramos, K.; Saly, M. J.; Chabal, Y. J. Precursor design and reaction mechanisms for the atomic layer deposition of metal films. *Coord. Chem. Rev.* **2013**, 257 (23), 3271-3281.

(9) Donald, C. B.; Halina, C.; Michael, B. H.; Majid, M.; Ruowen, W. Fluorinated tertiary alkoxides of some lanthanides: tris-trifluorotertiarybutoxides of lanthanum, praseodymium and europium. *Polyhedron* **1993**, 12 (24), 2955-2960.

(10) (a) Becker, R.; Weiß, J.; Winter, M.; Merz, K.; Fischer, R. A. New heterometallic copper zinc alkoxides: synthesis, structure properties and pyrolysis to Cu/ZnO composites. *J. Organomet. Chem.*

476 **2001**, 630 (2), 253-262. (b) Baum, T. H.; Bhandari, G.; Xu, C. Chemical vapor deposition precursors for
 477 deposition of copper. US6822107B1, 2004.

478 (11) For literature discussing the synthesis of non-fluorinated derivatives of [Cu(dmap)₂] which contain
 479 a tertiary amine, see: (a) Park, J. W.; Jang, H. S.; Kim, M.; Sung, K.; Lee, S. S.; Chung, T.-M.; Koo, S.;
 480 Kim, C. G.; Kim, Y. Synthesis of Cu(II) aminoalkoxide complexes and their unusual thermolysis to Cu(0).
 481 *Inorg. Chem. Commun.* **2004**, 7 (4), 463-466. (b) Kim, Y.; Kim, C. G.; Chung, T.-M.; Lee, S. S.; An, K.-
 482 S.; Yang, T. S.; Jang, H. S. Volatile copper aminoalkoxide complex and deposition of copper thin film
 483 using same. US6982341B1, 2006. (c) Tomaharu, Y.; Masaki, E.; Atsushi, S.; Akihiro, N.; Makoto, O.
 484 Copper Compound, Starting Material for Forming Thin Film, and Method for Manufacturing Thin Film.
 485 US2017044188A1, 2017.

486 (12) For literature discussing the synthesis of derivatives of [Cu(dmap)₂] containing a primary or
 487 secondary amine, see: (a) Chang, I.-S.; Willis, C. J. Fluorinated alkoxides. Part XI. Studies on highly
 488 fluorinated amino-alcohols and their metal derivatives. *Can. J. Chem.* **1977**, 55 (13), 2465-2472. (b) Hsu,
 489 P. F.; Chi, Y.; Lin, T. W.; Liu, C. S.; Carty, A. J.; Peng, S. M. Self-Reducible Cu^{II} Source Reagents for
 490 the CVD of Copper. *Chem. Vap. Depos.* **2001**, 7 (1), 28-31. (c) Peng-Fu, H.; Lin, T.-W.; Liun, C.-S.;
 491 Carty, A. J. Self-reducible and self-decomposing copper metalorganic complexes for deposition of electric
 492 conducting copper metal films. WO2001094291A1, 2001. (d) Chi, Y.; Hsu, P.-F.; Lin, T.-W.; Liu, C.-S.;
 493 Carty, A. J. Self-reducible copper(II) source reagents for chemical vapor deposition of copper metal.
 494 US6369256B1, 2002. (e) Chi, Y.; Hsu, P.-F.; Liu, C.-S.; Ching, W.-L.; Chou, T.-Y.; Carty, A. J.; Peng,
 495 S.-M.; Lee, G.-H.; Chuang, S.-H. Fluorinated aminoalkoxide Cu^{II} complexes: new CVD precursors for
 496 deposition of copper metal. *J. Mater. Chem.* **2002**, 12 (12), 3541-3550.

497 (13) For literature discussing new copper ALD processes with [Cu(dmap)₂], see: (a) Lee, B. H.; Hwang,
 498 J. K.; Nam, J. W.; Lee, S. U.; Kim, J. T.; Koo, S.-M.; Baunemann, A.; Fischer, R. A.; Sung, M. M. Low-
 499 Temperature Atomic Layer Deposition of Copper Metal Thin Films: Self-Limiting Surface Reaction of
 500 Copper Dimethylamino-2-propoxide with Diethylzinc. *Angew. Chem. Int. Ed.* **2009**, 48 (25), 4536-4539.
 501 (b) Knisley, T. J.; Ariyasena, T. C.; Sajavaara, T.; Saly, M. J.; Winter, C. H. Low Temperature Growth

502 of High Purity, Low Resistivity Copper Films by Atomic Layer Deposition. *Chem. Mater.* **2011**, 23 (20),
 503 4417-4419. (c) Kalutarage, L. C.; Clendenning, S. B.; Winter, C. H. Low-Temperature Atomic Layer
 504 Deposition of Copper Films Using Borane Dimethylamine as the Reducing Co-reagent. *Chem. Mater.*
 505 **2014**, 26 (12), 3731-3738. (d) Väyrynen, K.; Mizohata, K.; Räisänen, J.; Peeters, D.; Devi, A.; Ritala, M.;
 506 Leskelä, M. Low-Temperature Atomic Layer Deposition of Low-Resistivity Copper Thin Films Using
 507 Cu(dmap)₂ and Tertiary Butyl Hydrazine. *Chem. Mater.* **2017**, 29 (15), 6502-6510.
 508 (14) For select examples of the influence of ligand asymmetry on precursor volatility and/or melting point,
 509 see: (a) Park, K.-H.; Marshall, W. J. Remarkably Volatile Copper(II) Complexes of N,N'-
 510 Unsymmetrically Substituted 1,3-Diketimines as Precursors for Cu Metal Deposition via CVD or ALD.
 511 *J. Am. Chem. Soc.* **2005**, 127 (26), 9330-9331. (b) Baunemann, A.; Lemberger, M.; Bauer, A. J.; Parala,
 512 H.; Fischer, R. A. MOCVD of TaN Using the All-Nitrogen-Coordinated Precursors [Ta(NEtMe)₃(N-
 513 tBu)], [Ta(NEtMe)(N-tBu){C(N-iPr)₂(NEtMe)}₂], and [Ta(NMeEt)₂(N-tBu){Me₂N-N(SiMe₃)}]. *Chem.*
 514 *Vap. Depos.* **2007**, 13 (2-3), 77-83. (c) Eleter, M.; Daniele, S.; Brize, V.; Dubourdieu, C.; Lachaud, C.;
 515 Blasco, N.; Pinchart, A. Remarkable Influence of molecular structure of N,N'-unsymmetrically substituted
 516 1,3-amidinate and -guanidinate on the Volatility and the Thermal Stability of Precursors for HfO₂ Films
 517 via Liquid Injection-MOCVD. *ECS Trans.* **2009**, 25 (8), 151. (d) Chen, T.; Xu, C.; Baum, T. H.; Stauf,
 518 G. T.; Roeder, J. F.; DiPasquale, A. G.; Rheingold, A. L. New Tantalum Amido Complexes with Chelate
 519 Ligands as Metalorganic (MO) Precursors for Chemical Vapor Deposition (CVD) of Tantalum Nitride
 520 Thin Films. *Chem. Mater.* **2010**, 22 (1), 27-35. (e) Krasnopolski, M.; Hrib, C. G.; Seidel, R. W.; Winter,
 521 M.; Becker, H.-W.; Rogalla, D.; Fischer, R. A.; Edelmann, F. T.; Devi, A. Homoleptic Gadolinium
 522 Amidinates as Precursors for MOCVD of Oriented Gadolinium Nitride (GdN) Thin Films. *Inorg. Chem.*
 523 **2013**, 52 (1), 286-296. (f) Lubitz, K.; Sharma, V.; Shukla, S.; Berthel, J. H. J.; Schneider, H.; Hoßbach,
 524 C.; Radius, U. Asymmetrically Substituted Tetrahedral Cobalt NHC Complexes and Their Use as ALD
 525 as well as Low-Temperature CVD Precursors. *Organometallics* **2018**, 37 (7), 1181-1191. (g) Soussi, K.;
 526 Mishra, S.; Jeanneau, E.; Mantoux, A.; Daniele, S. Synthesis, characterization and thermal transport
 527 properties of heteroleptic N-alkyl triazenide complexes of titanium(IV) and niobium(V). *Polyhedron*

528 **2018**, 152, 84-89. (h) Gakiya-Teruya, M.; Jiang, X.; Le, D.; Üngör, Ö.; Durrani, A. J.; Koptur-Palenchar,
529 J. J.; Jiang, J.; Jiang, T.; Meisel, M. W.; Cheng, H.-P.; et al. Asymmetric Design of Spin-Crossover
530 Complexes to Increase the Volatility for Surface Deposition. *J. Am. Chem. Soc.* **2021**, 143 (36), 14563-
531 14572. (i) Samii, R.; Buttera, S. C.; Kessler, V.; O'Brien, N. J. Synthesis, Structure and Thermal Properties
532 of Volatile Indium and Gallium Triazenides. *Eur. J. Inorg. Chem.* **2022**, 2022 (24), e202200161.
533 (15) Yamauchi, Y.; Katagiri, T.; Uneyama, K. The First Generation and Stereospecific Alkylation of α -
534 Trifluoromethyl Oxiranyl Anion. *Org. Lett.* **2002**, 4 (2), 173-176.
535 (16) Goel, S. C.; Kramer, K. S.; Chiang, M. Y.; Buhro, W. E. Preparation and x-ray crystal structures of
536 volatile copper(II) alkoxides. *Polyhedron* **1990**, 9 (4), 611-613.
537 (17) Kunte, G. V.; Shivashankar, S. A.; Umarji, A. M. Thermogravimetric evaluation of the suitability of
538 precursors for MOCVD. *Meas. Sci. Technol.* **2008**, 19 (2), 025704.
539 (18) Barry, S. T. *Chemistry of Atomic Layer Deposition*; De Gruyter, 2022.
540 (19) Koponen, S. E.; Gordon, P. G.; Barry, S. T. Principles of precursor design for vapour deposition
541 methods. *Polyhedron* **2016**, 108, 59-66.
542 (20) Burger, B. J.; Bercaw, J. E. Vacuum Line Techniques for Handling Air-Sensitive Organometallic
543 Compounds. In *Experimental Organometallic Chemistry*, ACS Symposium Series, Vol. 357; American
544 Chemical Society, 1987; pp 79-115.
545 (21) Harris, R. K.; Becker, E. D.; Menezes, S. M. C. d.; Goodfellow, R.; Granger, P. NMR nomenclature.
546 Nuclear spin properties and conventions for chemical shifts (IUPAC Recommendations 2001). *Pure Appl.*
547 *Chem.* **2001**, 73 (11), 1795-1818.
548 (22) Sheldrick, G. SHELXT - Integrated space-group and crystal-structure determination. *Acta*
549 *Crystallographica Section A* **2015**, 71 (1), 3-8.
550 (23) Sheldrick, G. Crystal structure refinement with SHELXL. *Acta Crystallographica Section C* **2015**,
551 71 (1), 3-8.
552 (24) Dolomanov, O. V.; Bourhis, L. J.; Gildea, R. J.; Howard, J. A. K.; Puschmann, H. OLEX2: a
553 complete structure solution, refinement and analysis program. *J. Appl. Crystallogr.* **2009**, 42 (2), 339-341.

